



Atty. Dkt. No. 039262-0153

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tadahiro OHMI et al.

Title: SHOWER PLATE, PLASMA PROCESSING APPARATUS,  
AND PRODUCT MANUFACTURING METHOD

Appl. No.: 10/584,340

International 9/24/2004

Filing Date:

371(c) Date: 8/2/2006

Examiner: Keath T. Chen

Art Unit: 1792

Confirmation 2005

Number:

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated May 20, 2008, concerning the above-referenced patent application. Applicant respectfully petitions for a three-month extension of time.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 5 of this document.

Please amend the application as follows: